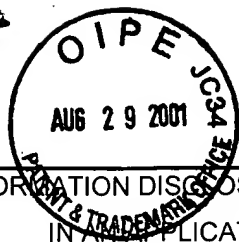


Part of #5

PATENT
Docket No.: 50544.00004 (NVLS 379)

INFORMATION DISCLOSURE CITATION IN THIS APPLICATION (Use several sheets if necessary)				DOCKET NUMBER		APPLICATION NUMBER	
				50544.00004 (NVLS 379)		09/872,796	
				APPLICANT			
				Craig L. Stevens, et al.			
				FILING DATE		GROUP ART UNIT	
				June 1, 2001		2812	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						
	L						
	M						
FOREIGN PATENT DOCUMENTS							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
	U						Yes No
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
	V	"Operator's Handbook," MB² Modular Sputtering System, Varian Semiconductor Equipment, TFS Technical Publications, October, 1994, Table of Contents, i - iv, Pages 1-2, 2-1, 2-6; 3-1, 3-2; 4-1, 4-4, 5-24.					
		"Drawings & Schematics Manual" Backbone Vol. 1, MB² Modular Sputtering System, Varian Semiconductor Equipment, TFS Technical Publications, June 1996, Table of Contents, i - vii; Index by Drawing Title, viii - xiii; Index by Drawing Number, xiv - xix.					
		"Various Engineering Drawings for Varian Semiconductor Processing System," Varian Associates, Exact Dates Unknown, Pages 244 245, 247 - 272- 274-1.					
EXAMINER				DATE CONSIDERED			
				12/11/02			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not information and not considered. Include copy of this with next communication to applicant.							

INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>				DOCKET NUMBER		APPLICATION NUMBER	
				50544.00004 (NVLS 379)		Unassigned	
				APPLICANT			
				Craig L. Stevens and Karl B. Levy			
				FILING DATE		GROUP ART UNIT	
				June 1, 2001		Unassigned	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
EK	A	5,186,718	02/16/93	Avi Tepman, et. al.	29	25.01	04/15/91
EK	B	4,917,556	04/17/90	Lawrence R. Stark, et. al.	414	217	05/26/89
EK	C	5,135,608	08/04/92	Ken Okutani	156	643	07/10/90
EK	D	5,314,541	05/24/94	Masasi Saito, et. al.	118	725	05/28/92
EK	E	6,048,154	04/11/00	Joe Wytman	414	217	10/02/96
EK	F	4,705,951	11/10/87	Frederick P. Layman, et. al.	250	442.1	04/17/86
EK	G	4,228,358	10/14/80	Geoffrey Ryding	250	457	10/14/80
EK	H	4,042,128	08/16/77	Robert L. Shrader	214	17 B	11/26/75
EK	I	5,518,542	05/21/96	Hiroyuki Matsukawa, et. al.	118	52	11/04/94
EK	J	4,851,101	07/25/89	Martin A. Hutchinson	204	298	09/18/87
EK	K	4,795,299	01/03/89	Donald R. Boys, et. al.	414	217	04/15/87
EK	L	5,676,590	10/14/97	Naoki Hiraoka	451	287	12/29/95
EK	M	5,753,133	05/19/98	Jerry Wong, et. al.	216	67	07/11/94
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EK	O	5,961,722	10/05/99	Gayle Buhner, et. al.	118	712	11/26/97
EK	P	6,007,675	12/28/99	Masato Toshima	156	345	12/01/97
EK	Q	5,186,594	02/16/93	Masato M. Toshima, et. al.	414	217	04/19/90
EK	R	5,512,320	04/30/96	Norman L. Turner, et. al.	427	255	04/13/94
EK	S	5,882,165	03/16/99	Dan Maydan, et. al.	414	217	09/10/97
EK	T	5,951,770	09/14/99	Ilya Perlov, et al.	118	719	06/04/97
FOREIGN PATENT DOCUMENTS							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
	U						Yes No

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<i>EK</i>	V	John F. O'Hanlon, et al: "Reduction of water aerosol contamination during pumping of a vacuum chamber from atmospheric pressure" <u>American Vacuum Society</u> , J. Vac.Sci.Technol. A 9 (5); Sep/Oct 1991, Pages 2802-2807
EXAMINER	<i>Eric K...</i>	DATE CONSIDERED <i>12/11/02</i>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not information and not considered. Include copy of this with next communication to applicant.		